

Abstract of Disclosure

The present invention discloses a radiator warning system of semiconductor manufacturing equipment. The radiator warning
5 system has a light foil floating with airflow of the radiator. When the radiator is operated normally, the light foil is blown by airflow of the radiator to touch a contact detecting apparatus, and when the radiator is operated abnormally, the light foil does not touch the contact detecting apparatus. At this moment, a warning apparatus
10 will send a warning signal. With the design of the claimed radiator warning system, the radiator can be inspected immediately while abnormal, and prevent the shutdown after exceeding temperature.